

1763
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Applicant : Masahiko NAKAMORI, et al.
App. No : 10/536,621
Filed : May 26, 2005
For : POLISHING PAD AND METHOD OF
PRODUCING SEMICONDUCTOR
DEVICE
Examiner : Unknown
Art Unit : 1763

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

March 2, 2006

(Date)

Katsuhiro Arai, Reg. No. 43,315COMMUNICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please be advised that a transliteration error in the spelling of the sixth named inventor's name is discovered. The sixth named inventor's name of record is Kimihiro Watanabe which was incorrectly transliterated from the original Japanese name and which should be Masahiro Watanabe.

The undersigned respectfully requests to correct the sixth inventor's first name to -- Masahiro-- in the file of the U.S. Patent and Trademark Office.

No fee is believed to be required for filing the communication, however, if any fees are required, please charge them to Account No. 11-1410,

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP.

Dated: March 2, 2006

By:

Katsuhiro Arai
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